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CONFIRMATION NO. 5704

<b>SERIAL NUMBER</b> 09/617,138	<b>FILING or 371(c) DATE</b> 07/14/2000 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2814	<b>ATTORNEY DOCKET NO.</b> 04329.2350		
<b>APPLICANTS</b> Osamu Arisumi, Yokohama-shi, JAPAN; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> JAPAN 11-200901 07/14/1999 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 09/01/2000						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and Acknowledged <u>/JOHN C INGHAM/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 23	<b>TOTAL CLAIMS</b> 20	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER LLP 901 NEW YORK AVENUE, NW WASHINGTON, DC 20001-4413 UNITED STATES						
<b>TITLE</b> MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE INCLUDING A CRYSTALLINE INSULATION FILM MADE OF PEROVSKITE TYPE OXIDE						
<b>FILING FEE RECEIVED</b> 1118	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			